



Transmission Spheres

Specifications

A complete offering of high quality transmission spheres (TS) designed to provide optimum interferometer performance. ZYGO's optics are specified and fully qualified to ensure accurate metrology for applications ranging from testing conventionally polished ultra smooth surfaces, to providing critical metrology feedback for small tool polishing processes. Each TS comes in a protective storage case with quality certification.

OVERVIEW

| | |
|------------------------|--|
| Measurement Capability | Used in conjunction with a laser Fizeau interferometer for the measurement of the surface form or transmitted wavefront of spherical optics and assemblies. Can also be utilized in the measurement of conic and aspheric shapes ⁽¹⁾ . |
| Diameters | 25 mm, 4 inch, 6 inch |
| Wavelength | 633 nm |
| Specifications | Apply to advertised TS f/# |
| Design | Low expansion reference element. Field coverage and residual axial ghosts are suitable for use with ZYGO Ring-of-Fire illumination. Controlled mid-spatial frequency content (PSD). Suitable for use in closed-loop feedback processes in work cells utilizing small pad polishing technologies. |

STANDARD PERFORMANCE (λ/10) TS

Best for metrology of test optics with ≤ 40% reflectivity.

| | |
|------------------------|---|
| Entrance Beam Diameter | 25 mm 4 inch (101.6 mm) 6 inch (152.4 mm) |
| f/# (25 mm) | f/0.58, f/0.7, f/1.0 |
| f/# (4 inch) | f/0.65, f/0.75, f/1.5, f/3.3, f/7.1, f/10.7 |
| f/# (6 inch) | f/0.8, f/1.1, f/2.2, f/3.5, f/5.4, f/7.2 |
| Reference Surface | 4% reflectivity λ/10 PV (λ = 633 nm) |

STANDARD PERFORMANCE DYNAFLECT™ (λ/10) TS

Best for metrology of test optics with > 40% reflectivity.

| | |
|------------------------|--|
| Entrance Beam Diameter | 4 inch (101.6 mm) |
| f/# (4 inch) | f/0.75, f/1.5, f/3.3, f/7.1, f/10.7 |
| Reference Surface | Dynalect coating λ/10 PV (λ = 633 nm) |

HIGH PERFORMANCE (λ/20) TS

Best for metrology of test optics with ≤ 40% reflectivity.

| | |
|------------------------|---|
| Entrance Beam Diameter | 4 inch (101.6 mm) |
| f/# (4 inch) | f/0.65, f/0.75, f/1.5, f/3.3, f/7.1, f/10.7 |
| f/# (6 inch) | f/0.8, f/1.1, f/2.2, f/3.5, f/5.4, f/7.2 |
| Reference Surface | 4% reflectivity λ/20 PV (λ = 633 nm) |

Specifications subject to change without prior notice.



ULTRASPHERE (λ/40) TS

The UltraSphere is designed to enable surface form metrology with an uncertainty in the RMS⁽²⁾ of ≤ 3.2 nm (λ/200 at 633 nm) when used with a ZYGO interferometer.

Best for metrology of test optics with ≤ 40% reflectivity.

| | |
|---|--|
| Entrance Beam Diameter | 4 inch (101.6 mm) |
| f/# (4 inch) | f/0.75, f/1.5, f/3.3 |
| Reference Surface | 4% reflectivity λ/40 PVr ⁽³⁾ (λ = 633 nm) < 2.5 nm RMSi ⁽⁴⁾ |
| Reference Surface Power Spectral Density (PSD) ⁽⁵⁾ | Mean Radial Profiles: < 5x10 ⁴ ·freq ^{-1.55} A ² μm Azimuthal Profiles: < 1x10 ⁵ ·freq ^{-1.55} A ² μm |
| Transmitted Wavefront Slope | Supports < 2 nm RMS cavity induced error ⁽⁶⁾ |

The UltraSphere TS products include absolute calibration of the reference surface and are shipped with the resulting MetroPro *.dat file and 37 term Zernike fit on a USB memory stick.

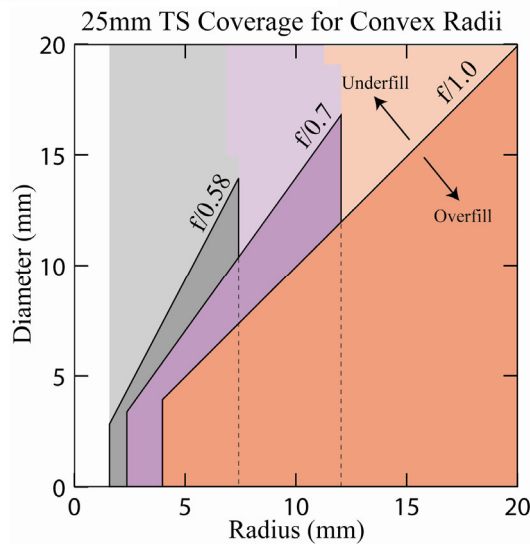
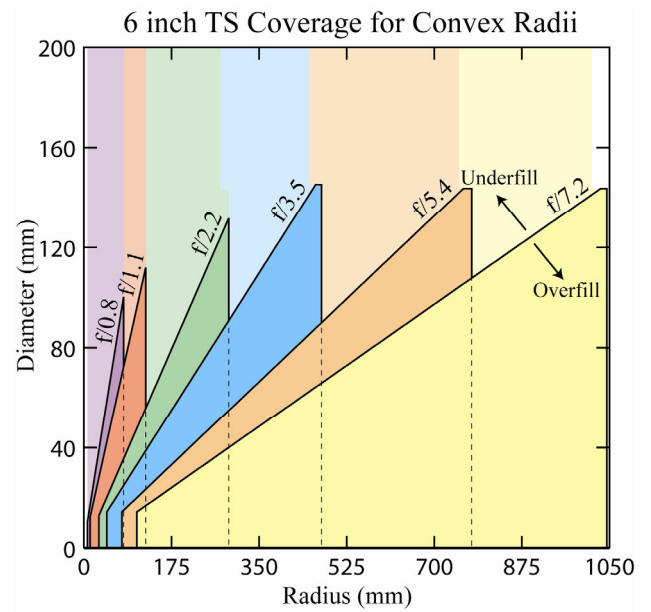
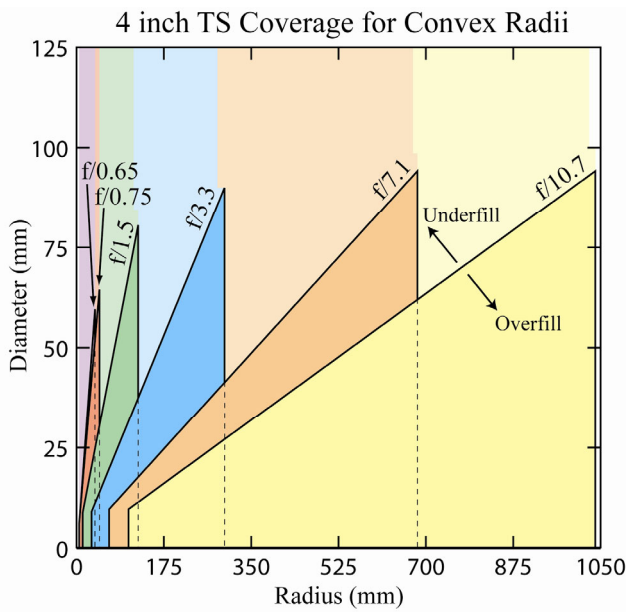
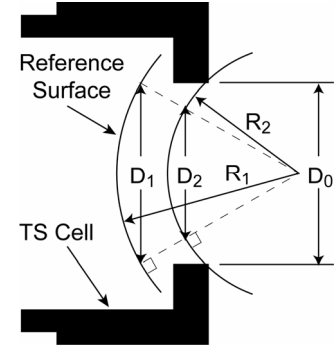
ADDITIONAL INFORMATION

To dynamically determine the recommended TS for an application use the *Transmission Sphere Selection Tool*, OMP-0495 or the *VeriFire Asphere Calculator Tool*, OMP-0525. Reference Drawings 6024-0034-02 and 6024-0048-02 provide mechanical dimensions of 4 inch and 6 inch TS's, respectively.

Notations

1. Direct measurement of an asphere with a spherical reference wavefront will introduce retrace errors. A ZYGO VeriFire Asphere interferometer minimizes retrace by measuring null zones of the asphere that match the f/# of the transmission sphere.
2. Assumes form metrology of smooth spherical surfaces, a well-nulled cavity, data averaging to minimize systematic noise, a suitably stable environment, and uncertainty estimation following ISO's "Guide to the Expression of Uncertainty in Measurement" (1995) with k=1.
3. PVr is defined as the 36 term Zernike fit plus 3 times the rms residual of the Zernike fit (PVr = PV_{36 Zernike} + 3 x σ_{36 Zernike Residual}).
4. RMSi is the irregularity after removing the best fit spherical surface per ISO 10110 part 5 (1996)/ISO 14999 Part 4 (2007) standards.
5. Spatial frequency band: 3/Clear Aperture to 0.2/Lateral Scale. PSD limits defined by the power law model of ISO 10110-8.
6. As-built TS wavefront slope is controlled to insure that the peak cavity induced retrace errors will contribute less than the specified RMS value up to reference-to-part radius ratios of 5:1. As an example, a 5:1 ratio for an f/0.75 TS corresponds to a reference surface of radius 48.2 mm and a test sphere of radius 9.64 mm. Cavities that yield ratios of > 5:1 may induce error that exceed the specified RMS.

| Part Number | Aperture | f/# | R ₁ (mm) | D ₀ (mm) | R ₂ (mm) | D ₁ (mm) | D ₂ (mm) |
|--------------|----------|------|---------------------|---------------------|---------------------|---------------------|---------------------|
| 6024-0472-01 | 25 mm | 0.58 | 8.0 | 14.8 | 7 | 14 | 12 |
| 6024-0474-01 | 25 mm | 0.7 | 12.0 | 19.0 | 11 | 17 | 16 |
| 6024-0476-01 | 25 mm | 1.0 | 20.0 | 24.1 | 17 | 20 | 17 |
| 6024-0454-XX | 4 inch | 0.65 | 38.7 | 62.0 | 36 | 60 | 56 |
| 6024-0444-XX | 4 inch | 0.75 | 48.2 | 65.5 | 45 | 64 | 60 |
| 6024-0430-XX | 4 inch | 1.5 | 121.2 | 93.7 | 115 | 81 | 76 |
| 6024-0399-XX | 4 inch | 3.3 | 298.0 | 89.2 | 282 | 90 | 85 |
| 6024-0404-XX | 4 inch | 7.1 | 681.7 | 98.1 | 674 | 96 | 95 |
| 6024-0410-XX | 4 inch | 10.7 | 1039.2 | 100.4 | 1030 | 97 | 96 |
| 6024-0458-XX | 6 inch | 0.8 | 80.0 | 104.9 | 77 | 100 | 97 |
| 6024-0455-XX | 6 inch | 1.1 | 123.3 | 128.4 | 118 | 112 | 107 |
| 6024-0414-XX | 6 inch | 2.2 | 290.0 | 164.1 | 274 | 132 | 125 |
| 6024-0413-XX | 6 inch | 3.5 | 475.8 | 164.1 | 458 | 149 | 130 |
| 6024-0417-XX | 6 inch | 5.4 | 776.4 | 164.1 | 761 | 147 | 141 |
| 6024-0405-XX | 6 inch | 7.2 | 1045.0 | 164.1 | 1022 | 145 | 142 |



Specifications subject to change without prior notice.